

PTO-1449  <b>Information Disclosure Citation In an Application</b>		Application No. <b>10/052,886</b>		Applicant(s) <b>Seemant (nmi) Choudhary et al.</b>	
		Docket Number <b>064731.0263</b>	Group Art Unit <b>2633</b>	Filing Date <b>January 18, 2002</b>	

**U.S. PATENT DOCUMENTS**

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A						
B						

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
C	GB 2 370 473	06/26/2002	United Kingdom				
D	JP 3-251827	11/11/1991	JAPAN				
E	JP 8-181391	12/07/1996	JAPAN				
F							

**NON-PATENT DOCUMENTS**

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
G	Office Action for Application No. 2003-009997, received 12/16/2008, 1 page	12/16/2008
H	Tetsuya et al., "Optical Phase Detection System," Patent Abstracts of Japan, Publication No. 04-249434, 2 pages, September 4, 1992	09/04/1992
I	Takashi et al., "Surface Emitting Laser, Surface Emitting Laser Array, and Optical Information Processing Equipment," Patent Abstracts of Japan, Publication No. 08-181391, 1 page, December 7, 1996	12/07/1996
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P		
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EXAMINER /Agustin Bello/ (01/31/2009)	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /A.B./